



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 24, 2026

IGI Report Number

LG829619348

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

11.81 X 8.04 X 5.41 MM

GRADING RESULTS

Carat Weight

5.03 CARATS

Color Grade

E

Clarity Grade

VS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

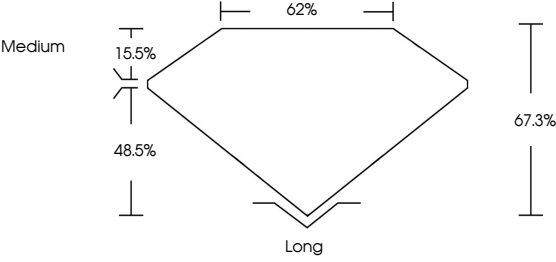
 LG829619348

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

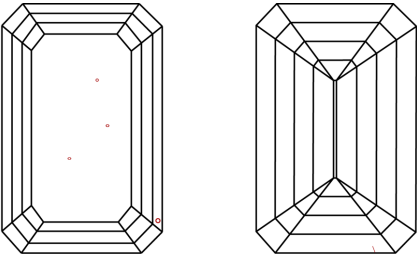
Report verification at igi.org

LG829619348

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

Sample Image Used



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Diagram of an emerald cut diamond showing proportions: Table 15.5%, Depth 48.5%, Length 62%, Width 67.3%, and Girdle Medium.

IGI



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EMERALD CUT

11.81 X 8.04 X 5.41 MM

5.03 CARATS

E

VS 2

67.3%

62%

Medium

Long

EXCELLENT

EXCELLENT

NONE

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Culet

Polish

Symmetry

Fluorescence

Inscription(s)

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Type IIa